



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 2, 2026
IGI Report Number **LG795699785**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **MARQUISE BRILLIANT**
Measurements **13.43 X 6.52 X 4.17 MM**

GRADING RESULTS

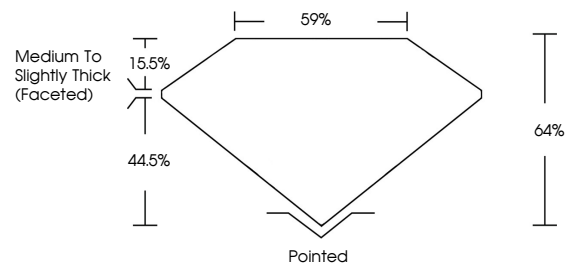
Carat Weight **2.05 CARATS**
Color Grade **E**
Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG795699785**

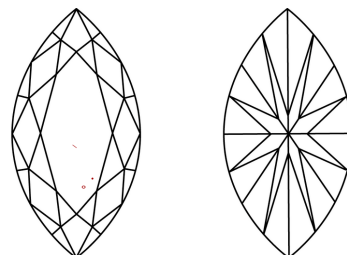
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

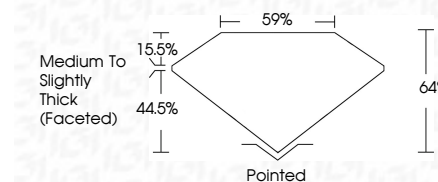
D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



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MARQUISE BRILLIANT
13.43 X 6.52 X 4.17 MM
Carat Weight **2.05 CARATS**
Color Grade **E**
Clarity Grade **VS 1**
Depth **64%**
Table **59%**
Girdle **Medium to Slightly Thick (Faceted)**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
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